

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicants: | Masahiko HATA et al. | Confirmation: | 4111 |
| Serial No.: | 10/577,069 | Art Unit: | 2891 |
| Filed: | June 20, 2006 | Examiner: | J. Slutsker |
| For: | Method for manufacturing compound semiconductor substrate | | |

AMENDMENT

MAIL STOP AMENDMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

September 15, 2009

Sir:

This Amendment responds to the Office Action of April 1, 2009. The response date has been extended by a three-month petition for extension of time.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.